



Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 110157.99	APPLICATION NO. 08/994,758	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Kenji NISHI		
		FILING DATE December 19, 1997			GROUP 2851	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
<i>AM</i>		5,506,684	4/1996	OTA et al.		—
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
<i>AM</i>		JP A-4-196513 (w/abstract)	7-1992	Japan		—
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
<i>AM</i>		Buckley et al., "Step and scan: A systems overview of a new lithography tool", SPIE Vol. 1088 Optical/Laser Microlithography II (1989), p. 424-433.				
EXAMINER	<i>Alan Mathews</i>				DATE CONSIDERED <i>12-7-2001</i>	
Examiner:	Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					